



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 5, 2026	
IGI Report Number	LG771653653
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	9.38 X 6.43 X 3.96 MM

GRADING RESULTS

Carat Weight	1.50 CARAT
Color Grade	E
Clarity Grade	VS2

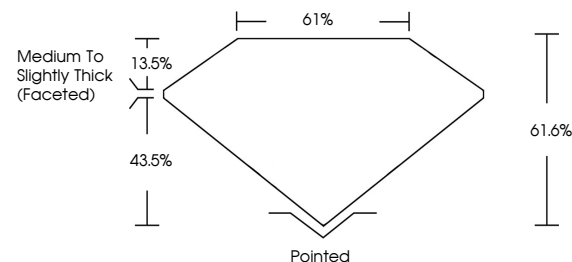
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG771653653

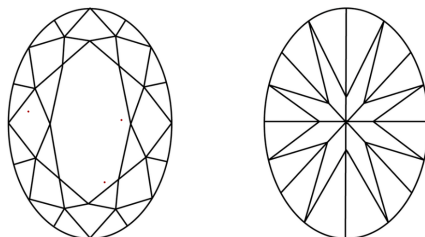
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG771653653
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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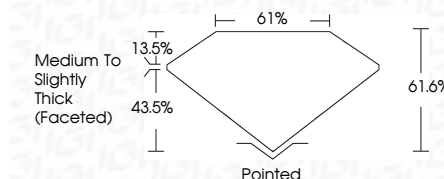
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www.igi.org

February 5, 2026	1.50 CARAT
GIA Report No. LG771653653	E
DIAM BRILLIANT	VVS 2
	61.6%
	61%
	Medium to Slightly Thick (Faceted)
	Pointed
	EXCELLENT
	EXCELLENT
	NONE
	681 LG771653653

Comments: This is a very young diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA